

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date February 27, 2009

In re the Application of

Naoto NAKAMURA et al.

Application No.: 10/528,069

Filed: July 10, 2005

For: THERMAL TREATMENT APPARATUS, METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING SUBSTRATE



Group Art Unit: 2893

Examiner: H. TRINH

Docket No.: 122733

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired January 27, 2009, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 215690 in the amount of \$130.00 in payment for:

- ☒ Extension fee for response within first month pursuant to §1.136(a) (\$130.00)
- ☐ Extension fee for response within second month pursuant to §1.136(a) (\$490.00)
- ☐ Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1,110.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Daniel A. Tanner, III

Registration No. 54,734
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OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;

Charge any fee due to our
Deposit Account No. 15-0461